

RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 1792

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Jin Zhao et al. Confirmation No.: 4854
Application Number : 10/623,757
Filed : July 21, 2003
Title : MAINTAINING A REACTOR CHAMBER OF A CHEMICAL
VAPOR DEPOSITION SYSTEM
TC/Art Unit : 1792
Examiner: : Francis P. Smith

Docket No. : TI-35855 (0025.0220)
Customer No. : 23494

OK to
enter
C. Quen
7/16/08

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AND RESPONSE TO OFFICE ACTION

Responsive to the Final Office Action mailed June 12, 2008, and pursuant to
37 C.F.R. § 1.116, Applicants propose that this application be amended as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks follow the amendments section of this paper.